

Fig. 1A
SIDE VIEW

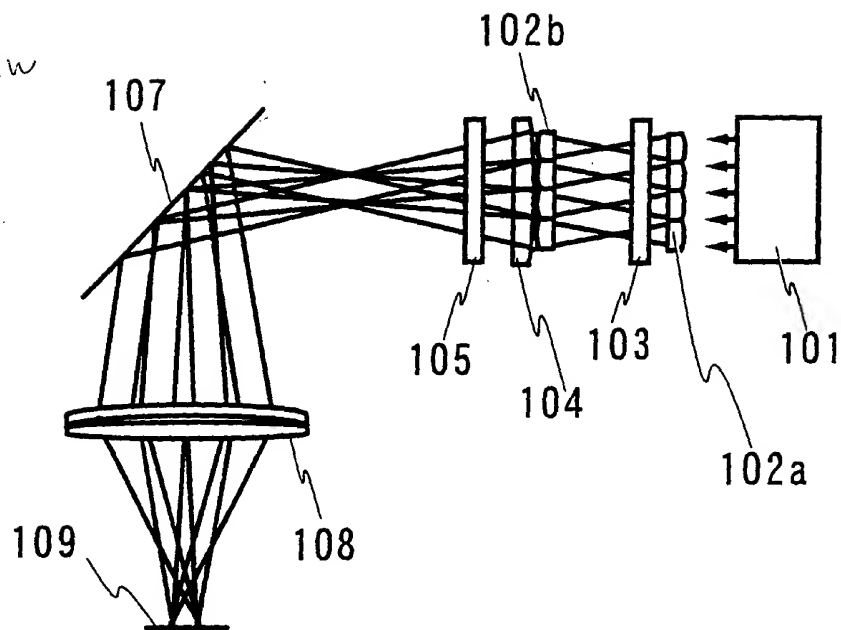
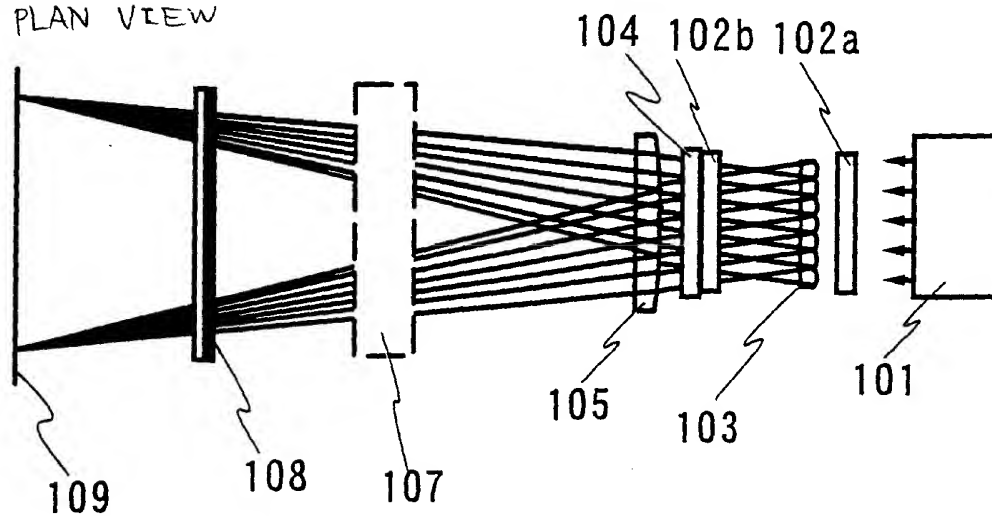


Fig. 1B
PLAN VIEW



65

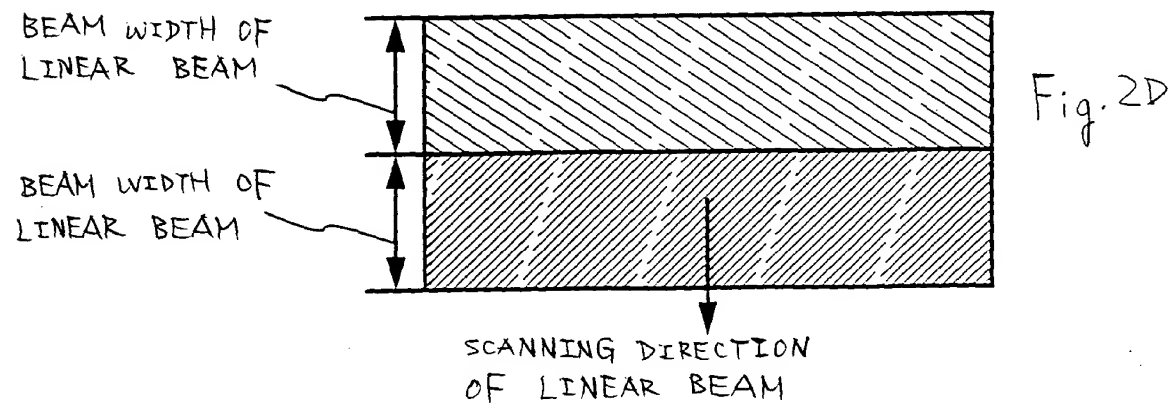
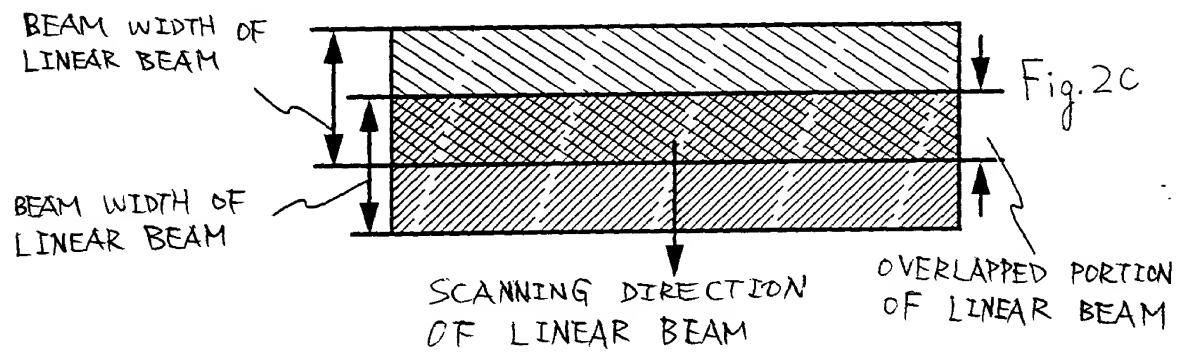
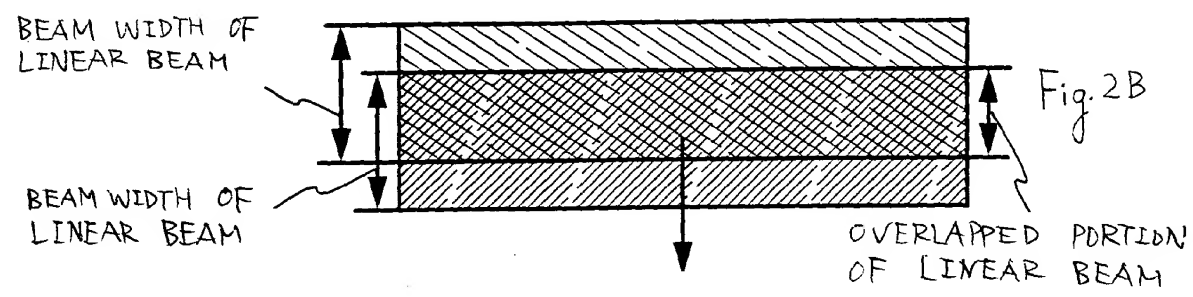
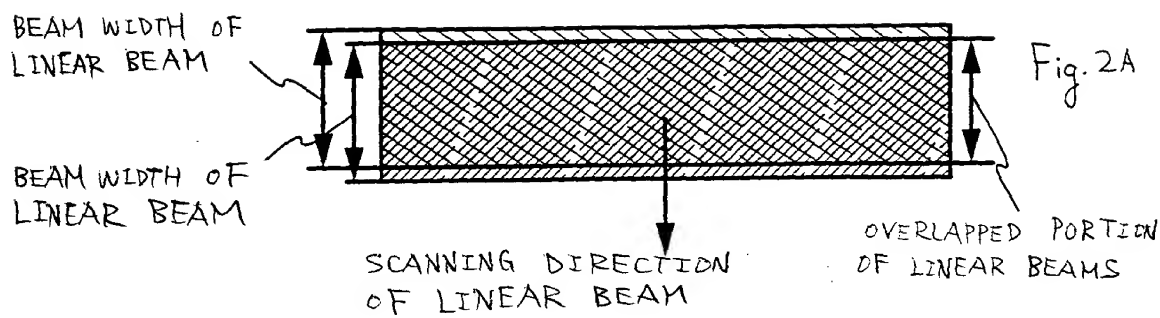


Fig. 3

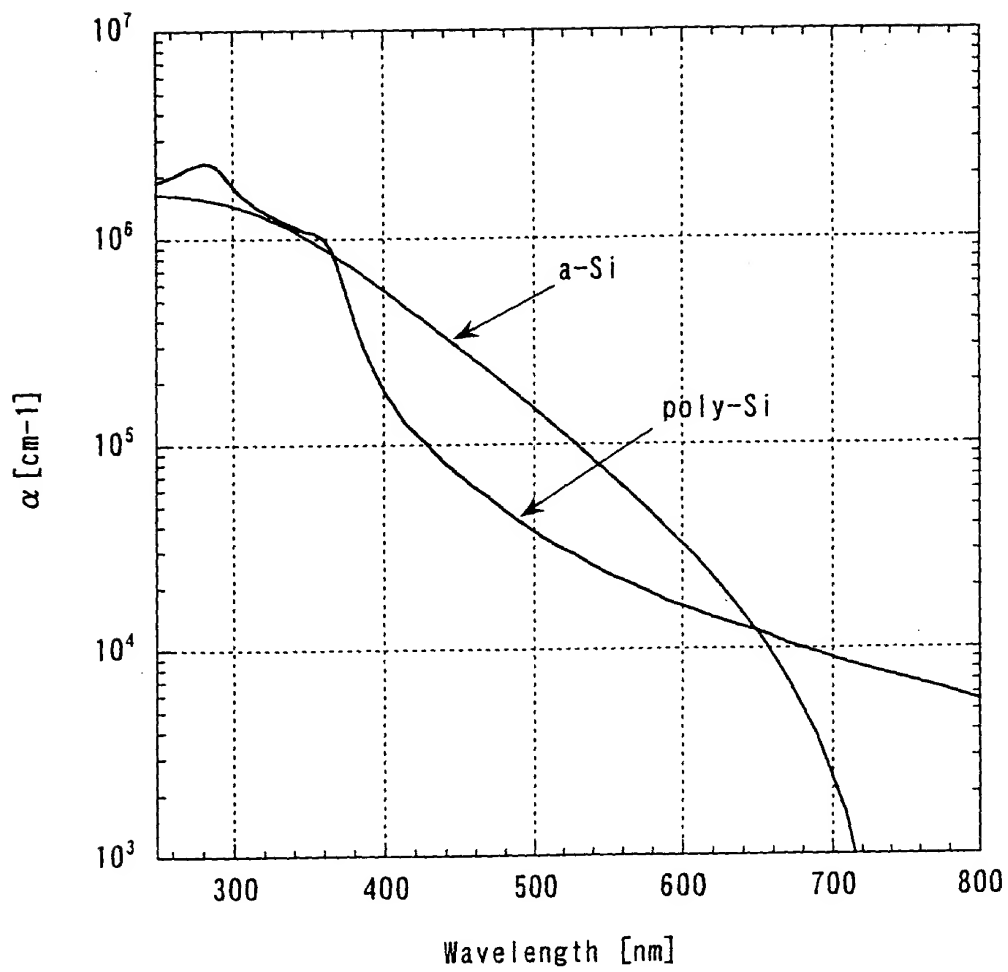


Fig. 4A

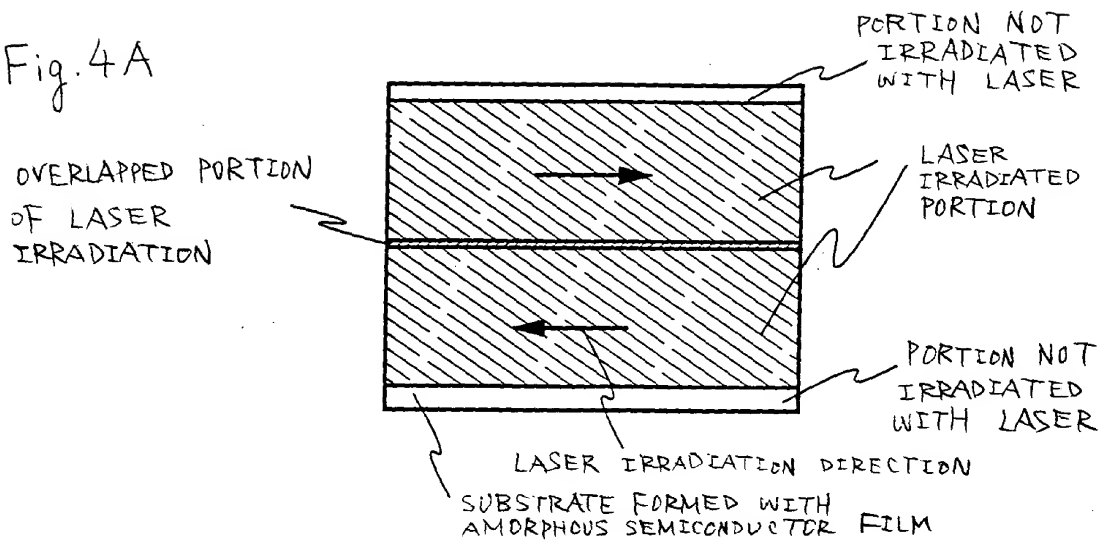


Fig. 4B

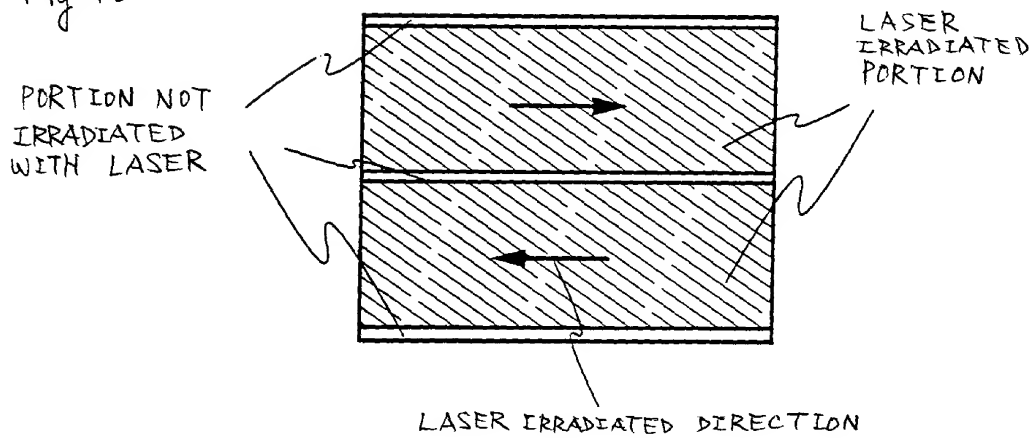


Fig. 4C

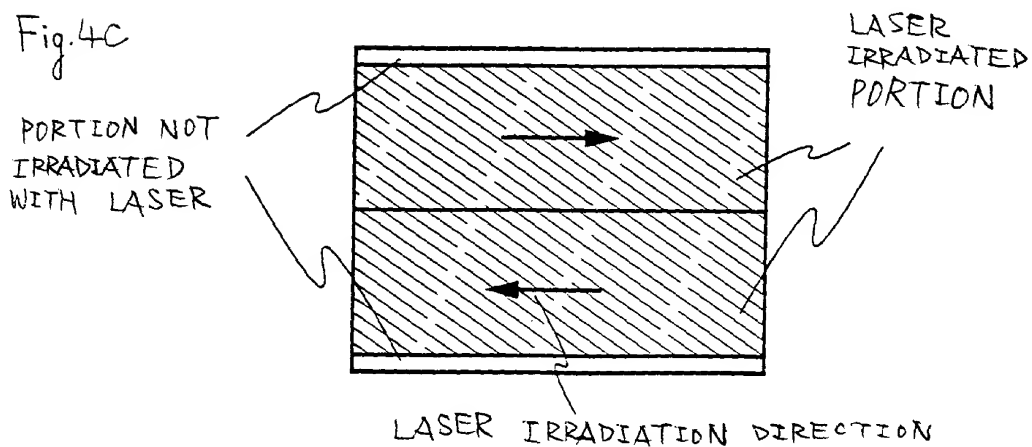


Fig. 5A
SIDE VIEW

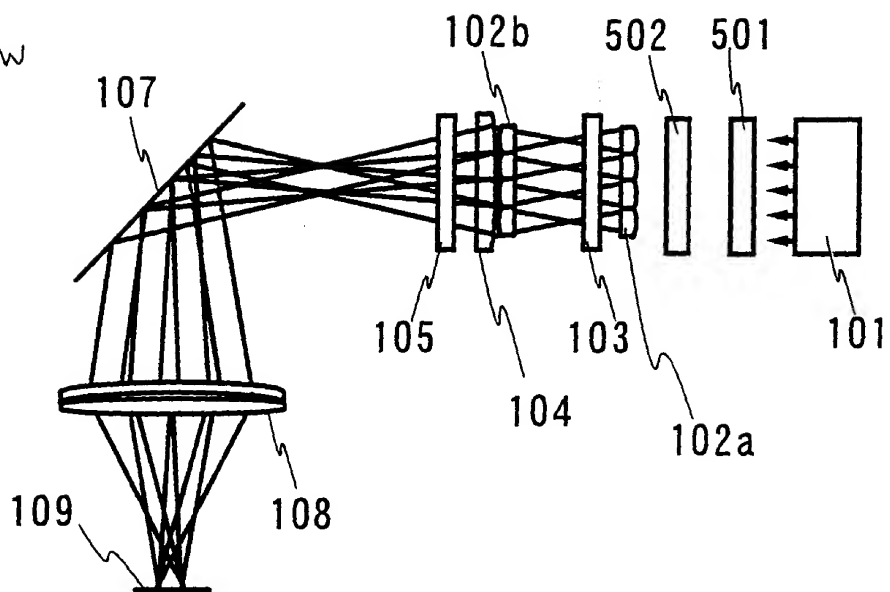
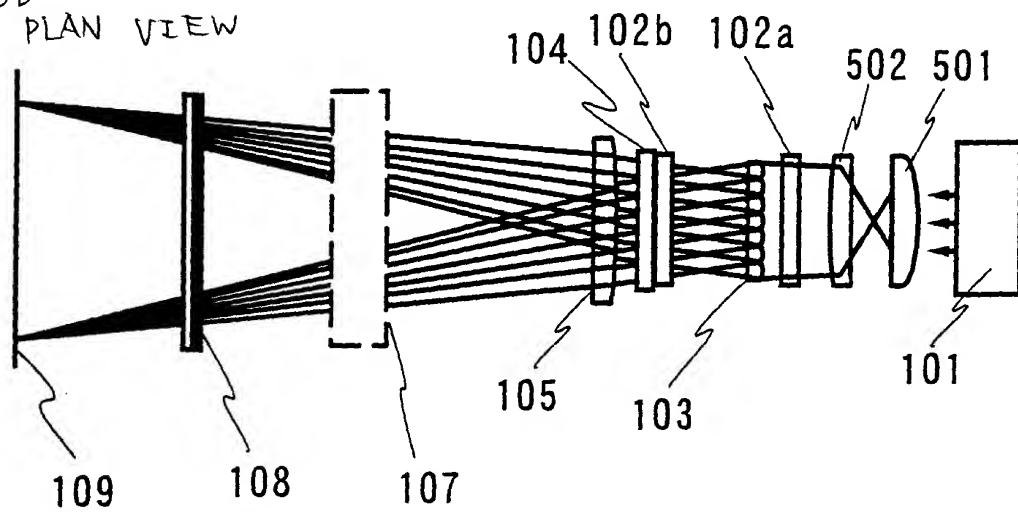
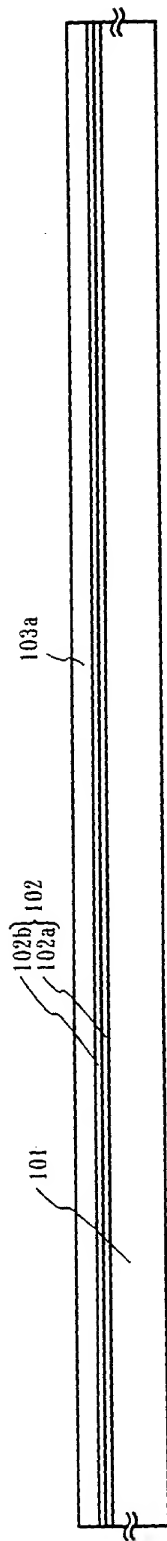


Fig. 5B
PLAN VIEW



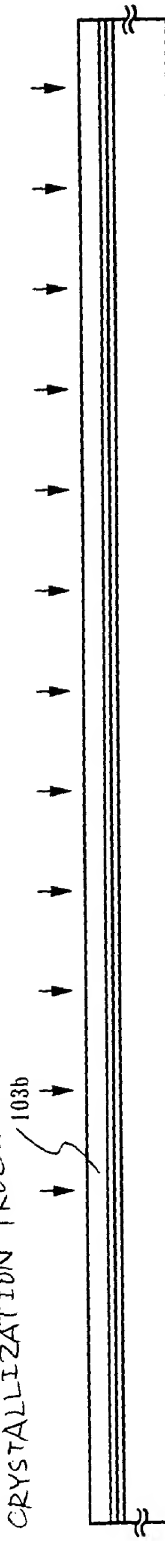
FORMATION OF UNDERLYING FILM AND AMORPHOUS SEMICONDUCTOR FILM

Fig. 6A



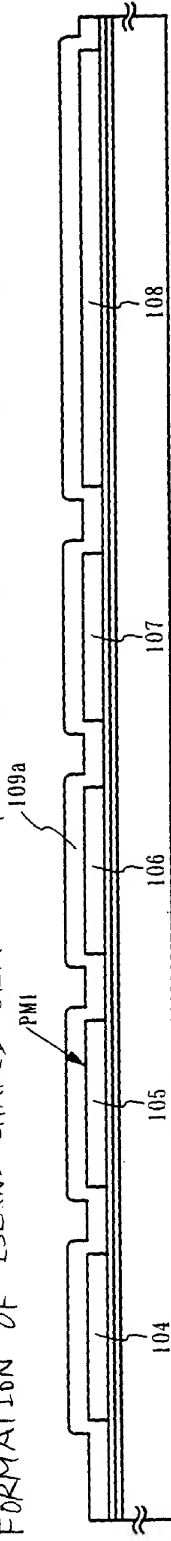
CRYSTALLIZATION PROCESS

Fig. 6B



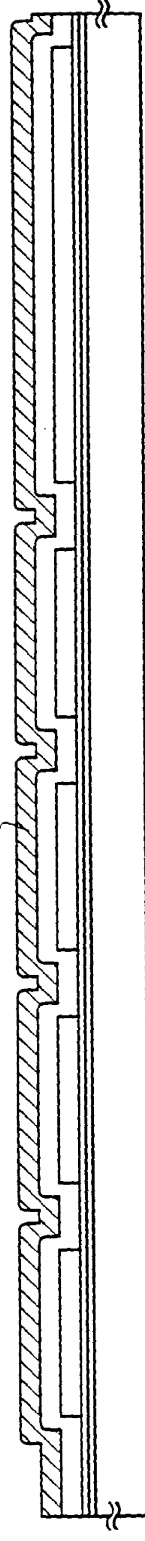
FORMATION OF ISLAND-SHAPED SEMICONDUCTOR LAYER AND GATE INSULATING FILM

Fig. 6C



FORMATION OF HEAT-RESISTANT CONDUCTIVE LAYER

Fig. 6D



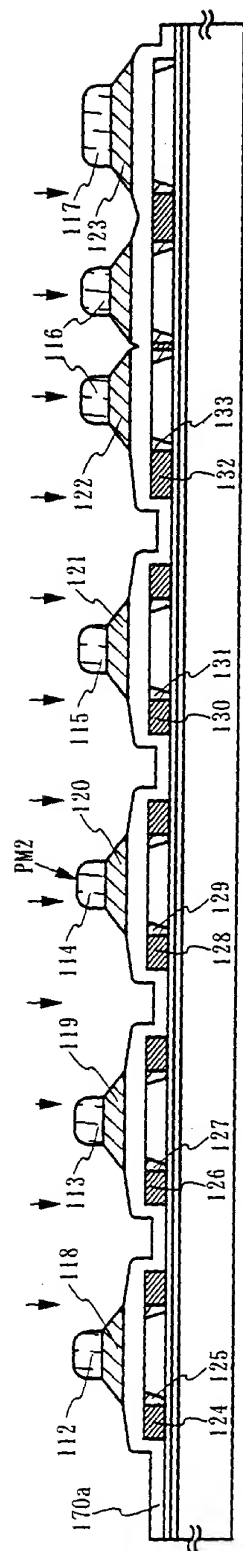
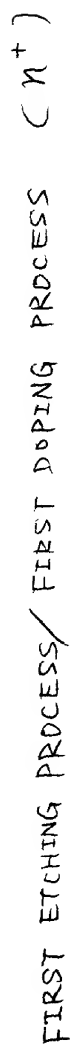


Fig. 8A FORMATION OF FIRST INTERLAYER INSULATING FILM

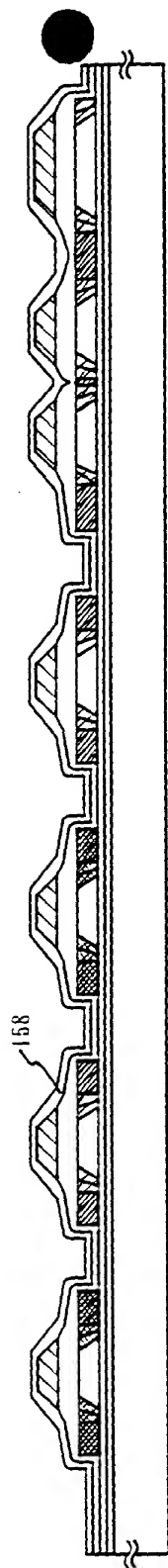


Fig. 8B FORMATION OF SECOND INTERLAYER INSULATING FILM AND CONTACT HOLE AND WIRING AND PIXEL ELECTRODE

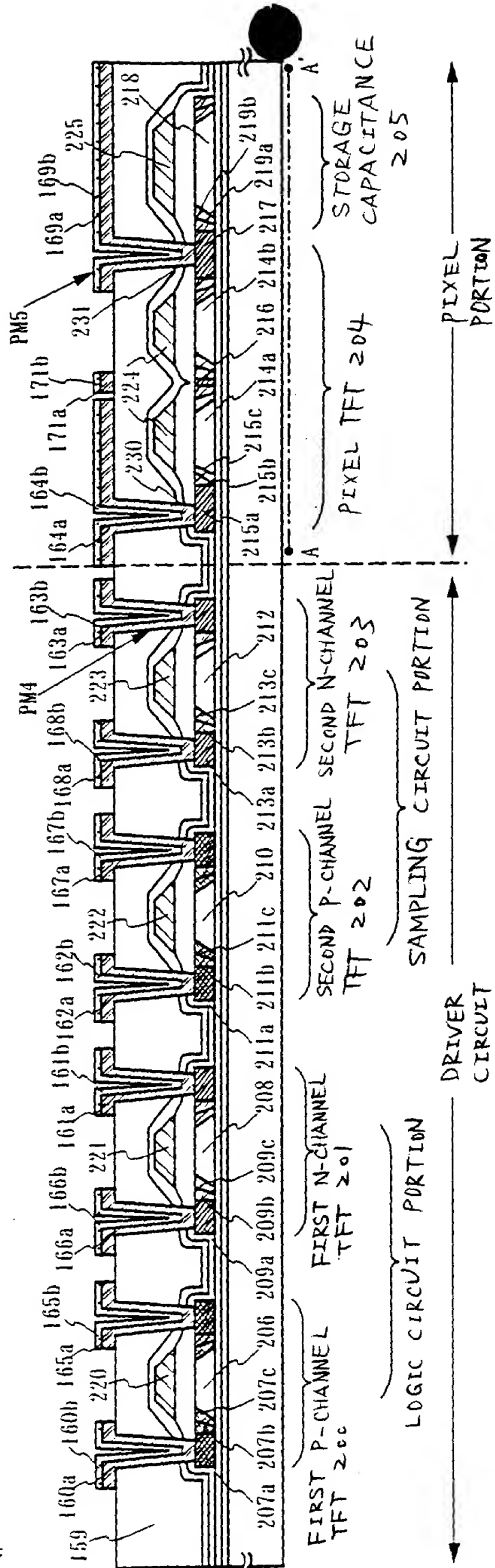


Fig. 9A

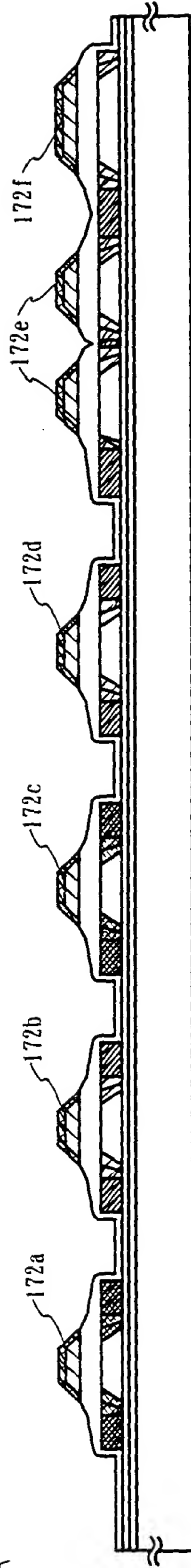


Fig. 9B

FORMATION OF FIRST INTERLAYER INSULATING FILM

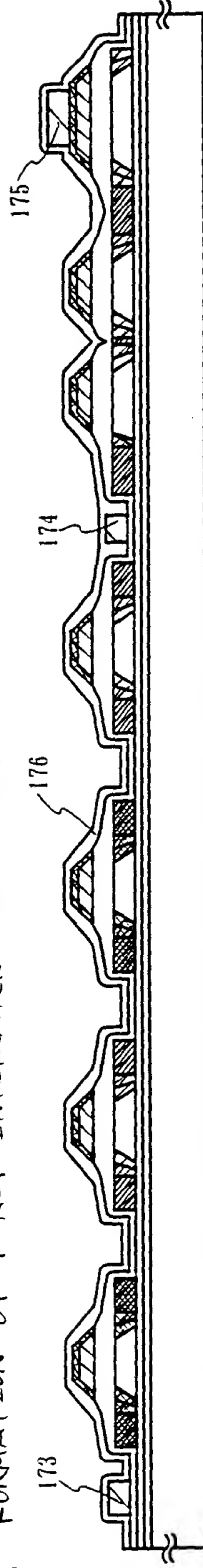
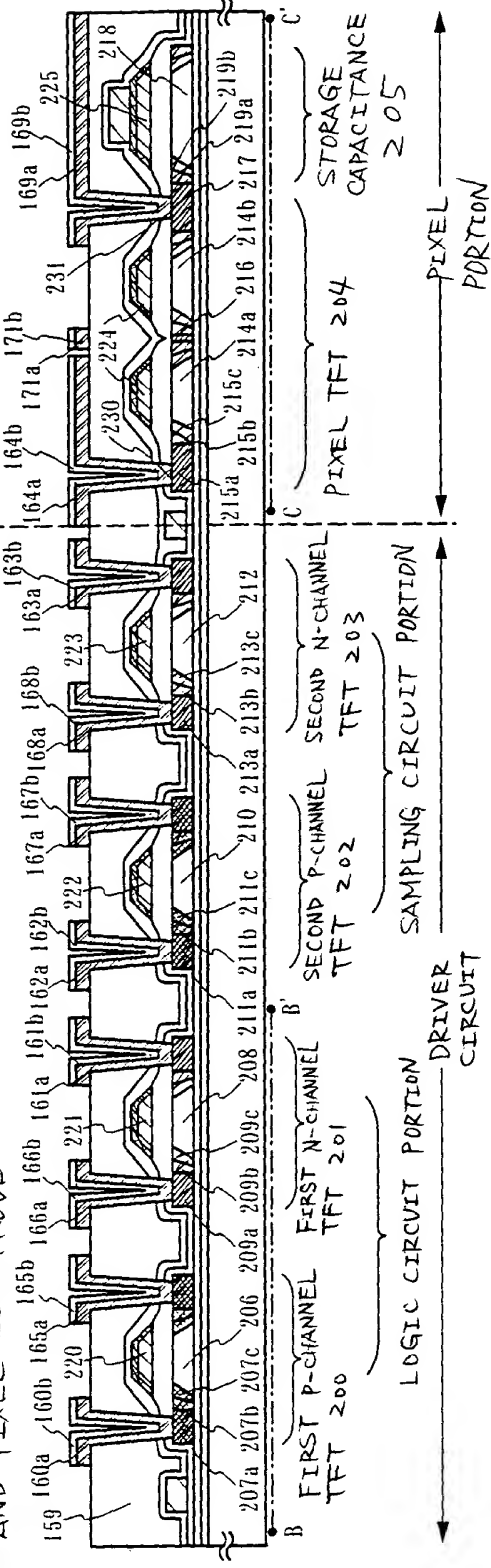


Fig. 9C

FORMATION OF SECOND INTERLAYER INSULATING FILM AND CONTACT HOLE AND WIRING



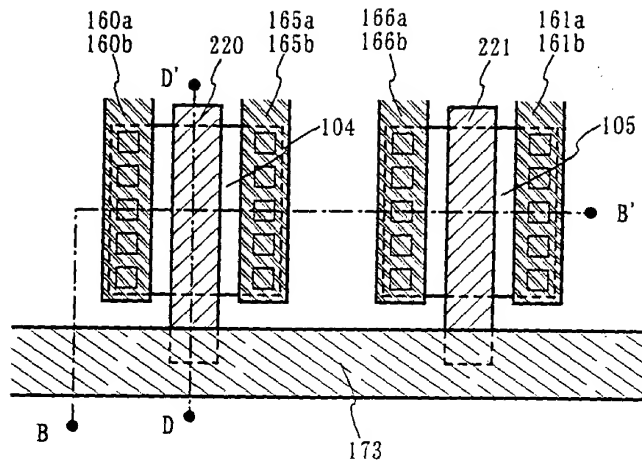


Fig. 10A

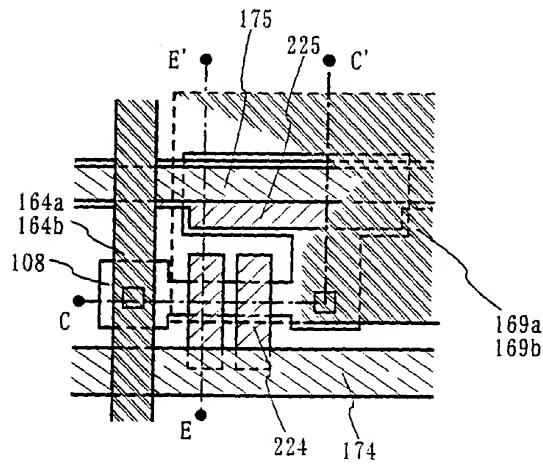


Fig. 10B

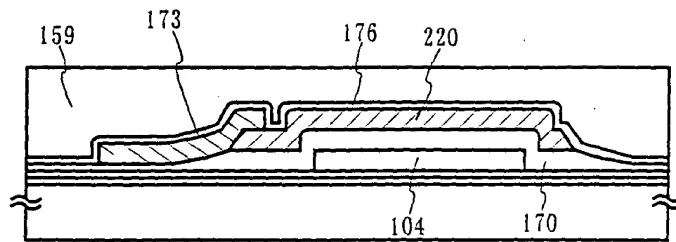


Fig. 11A

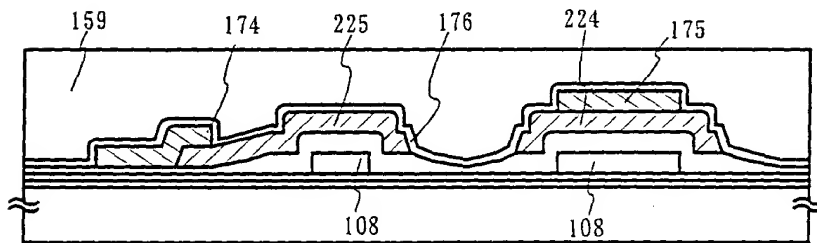


Fig. 11B

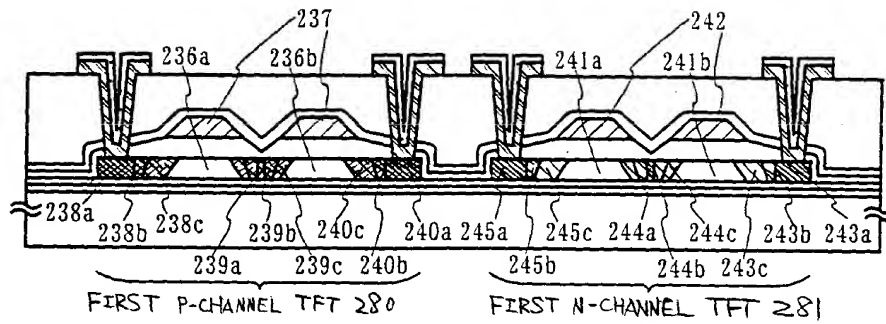


Fig. 12A

LOGIC CIRCUIT PORTION

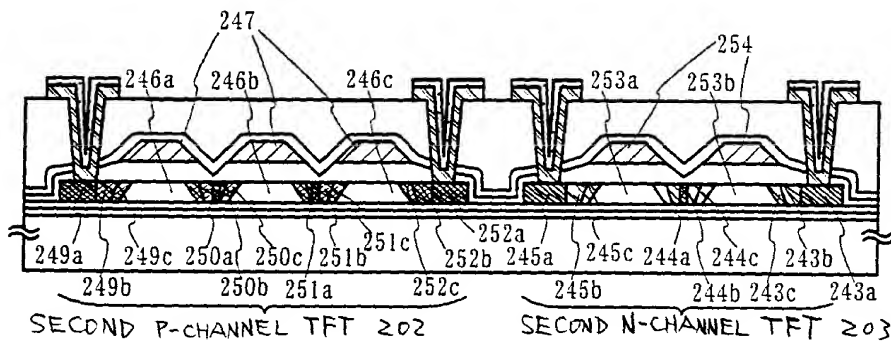


Fig. 12B

SAMPLING CIRCUIT PORTION

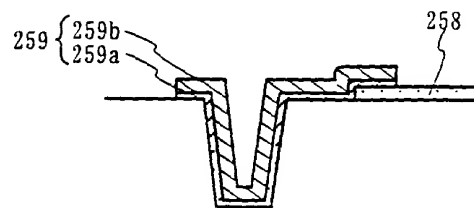
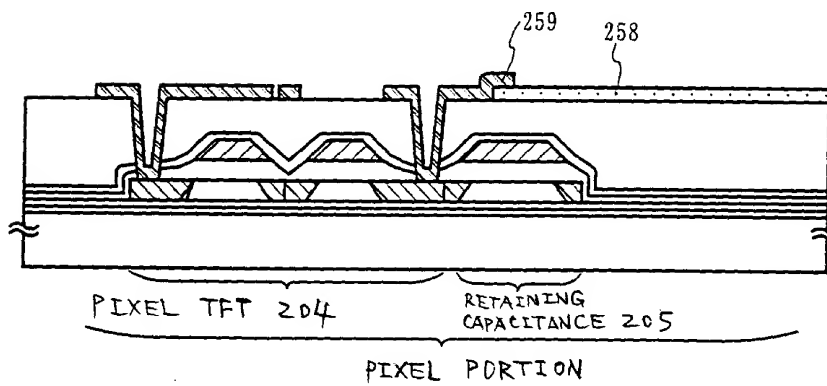
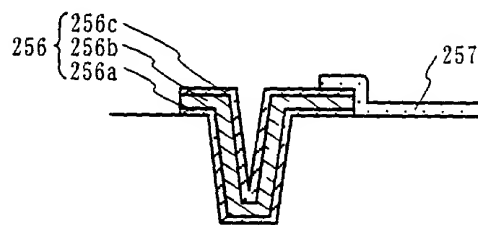
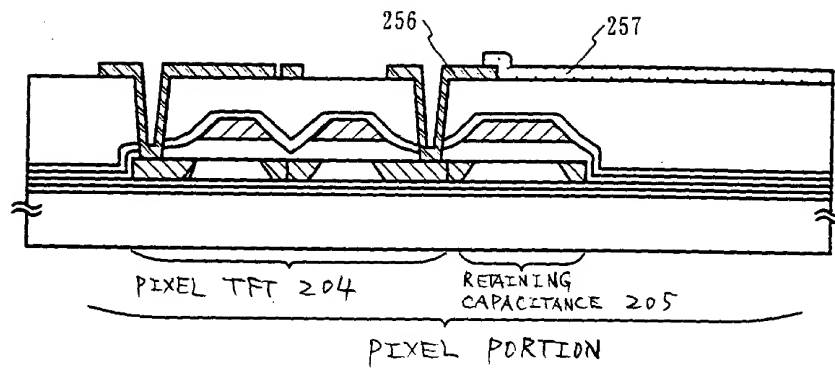


Fig. 14

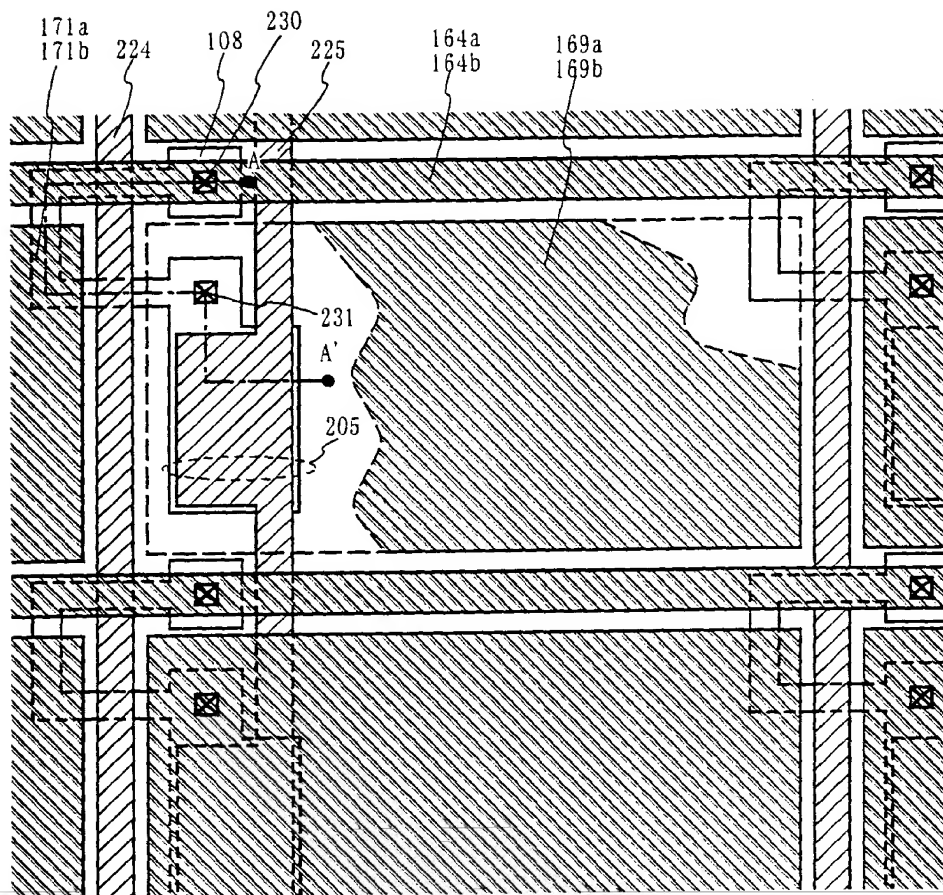


Fig. 14

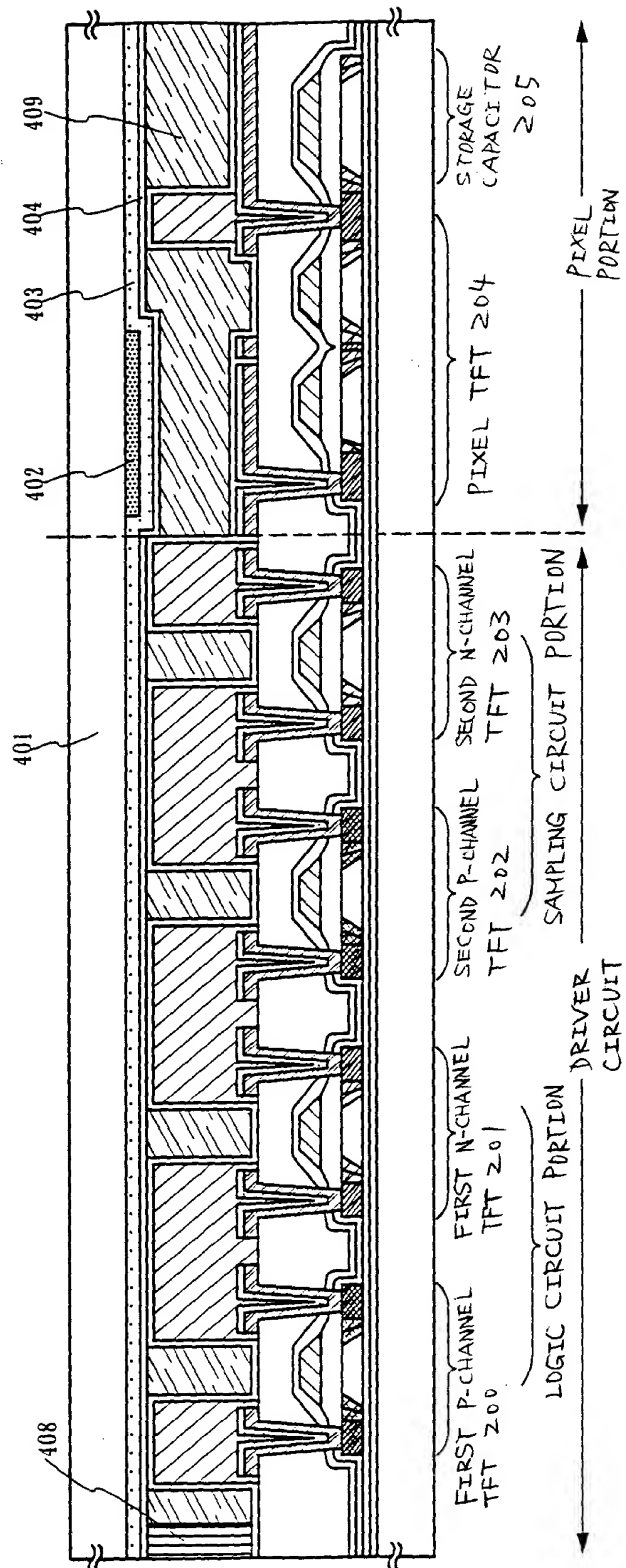
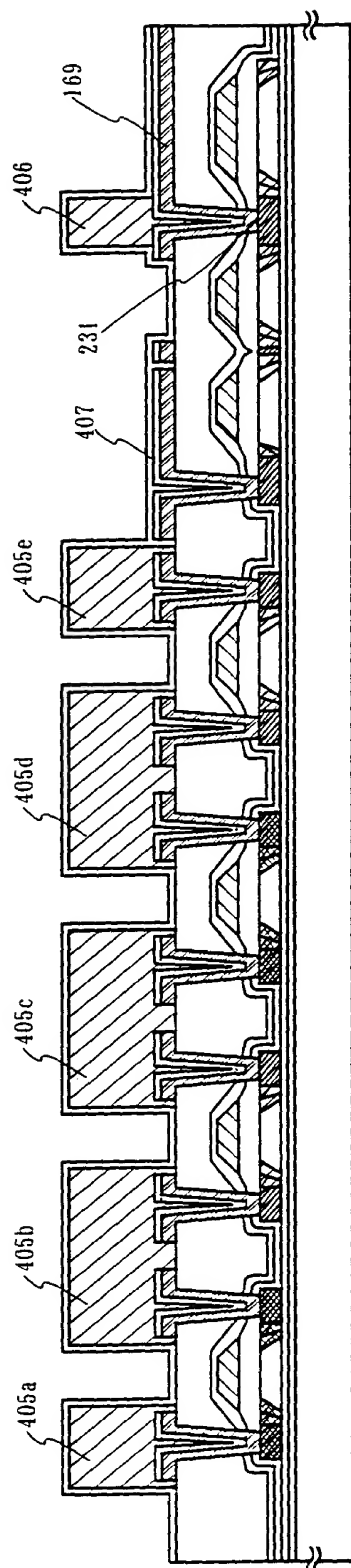


Fig. 16

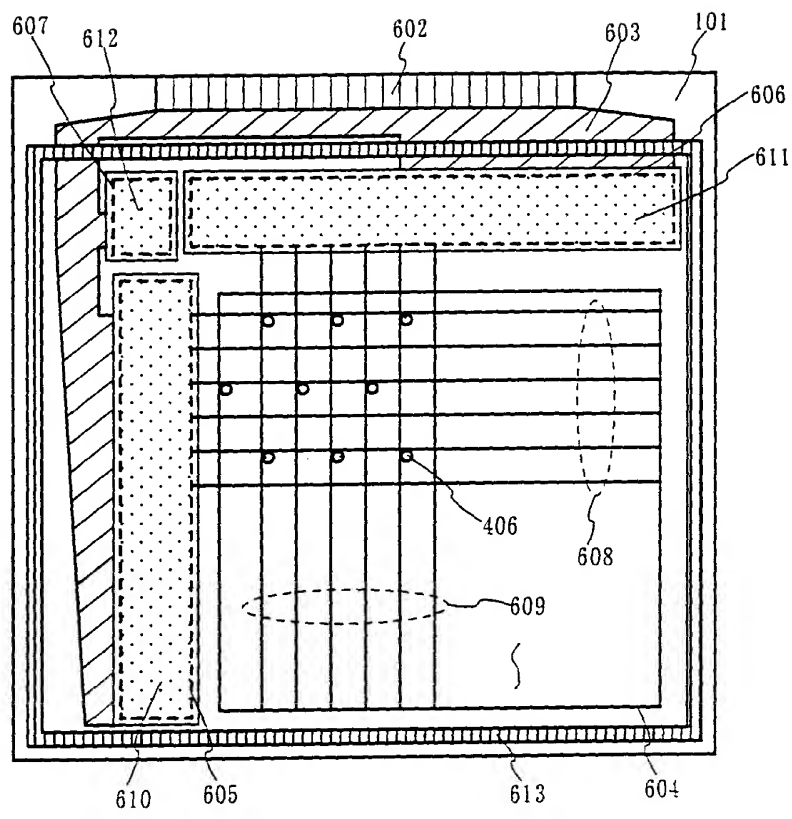


Fig. 16

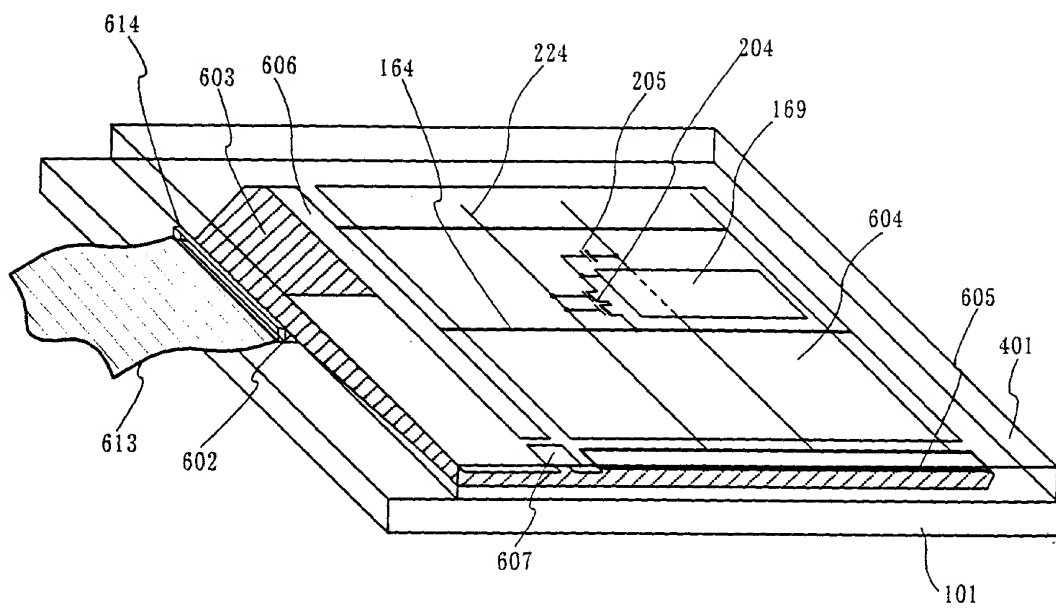


Fig. 17

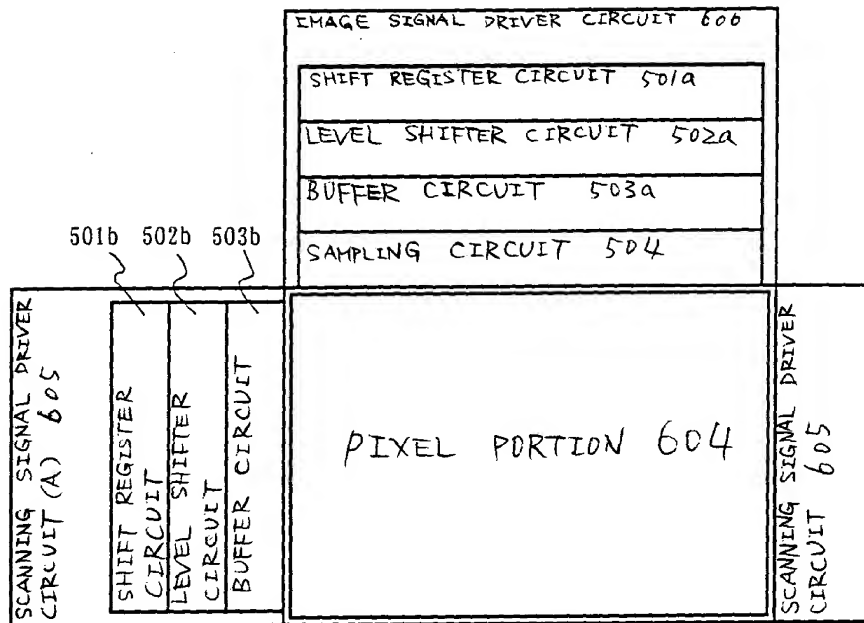
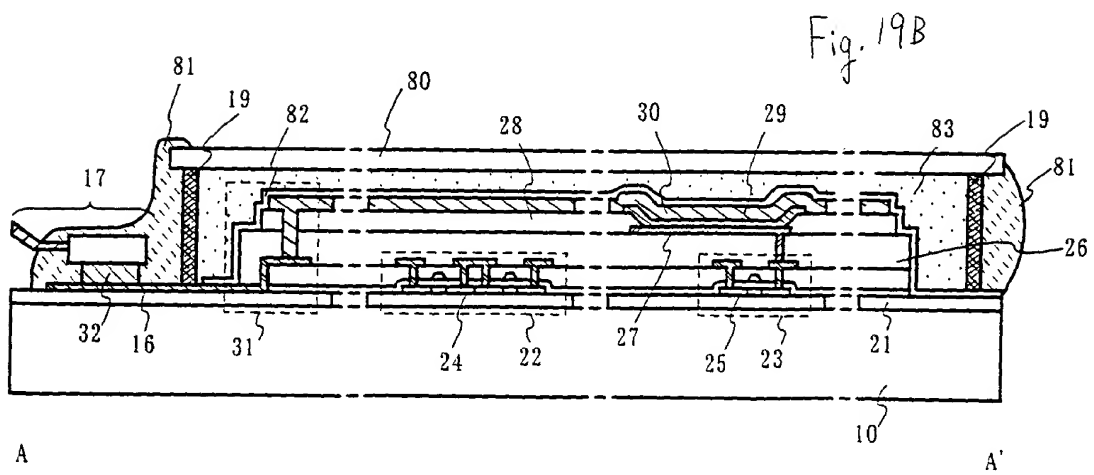
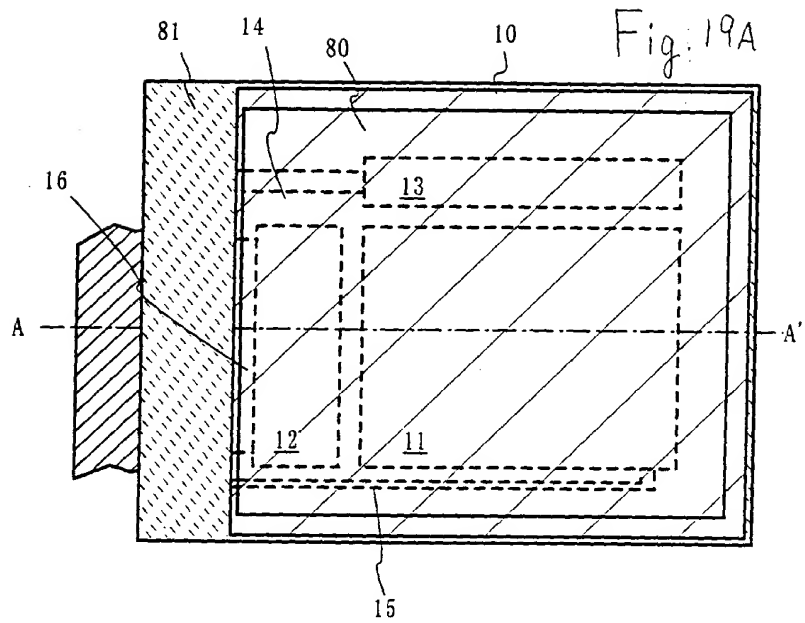


Fig. 18



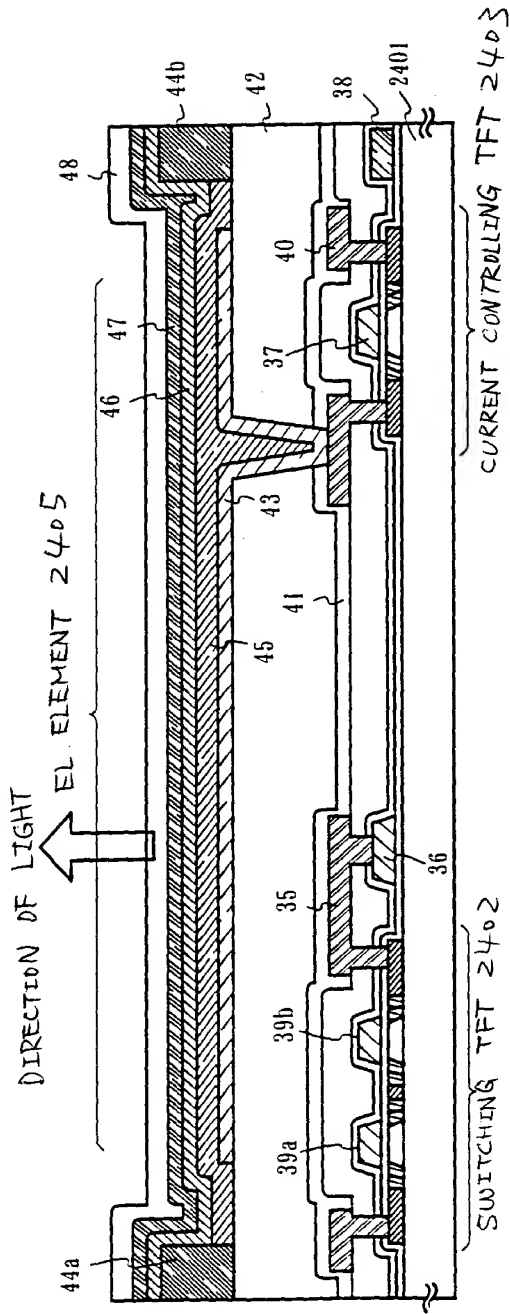


Fig. 20A

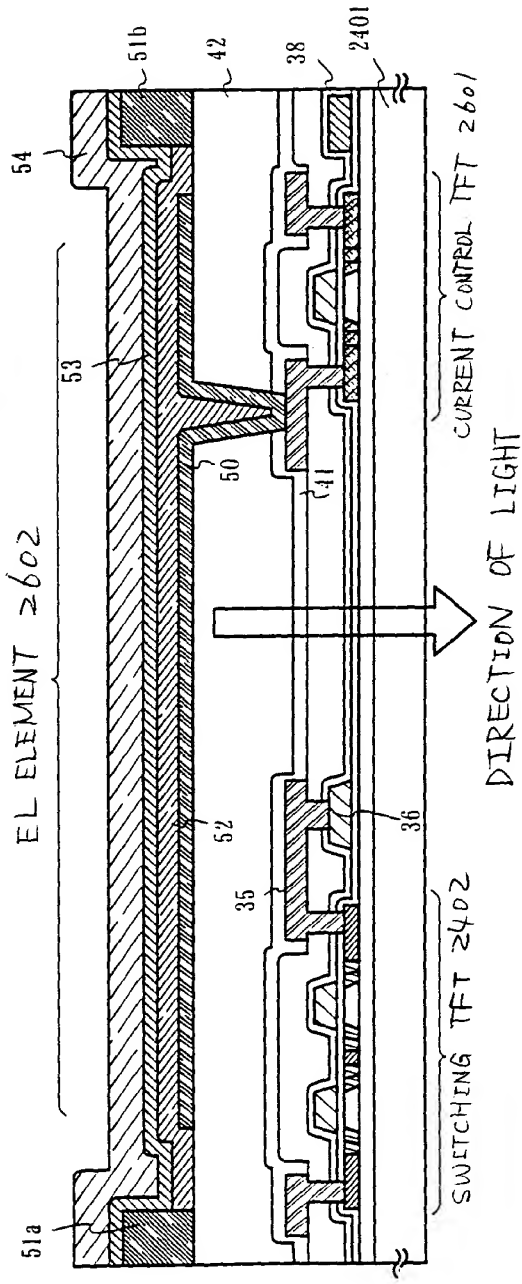
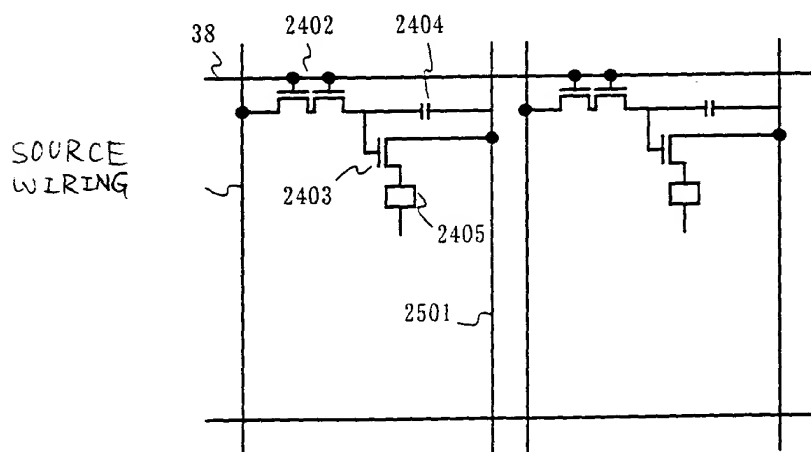
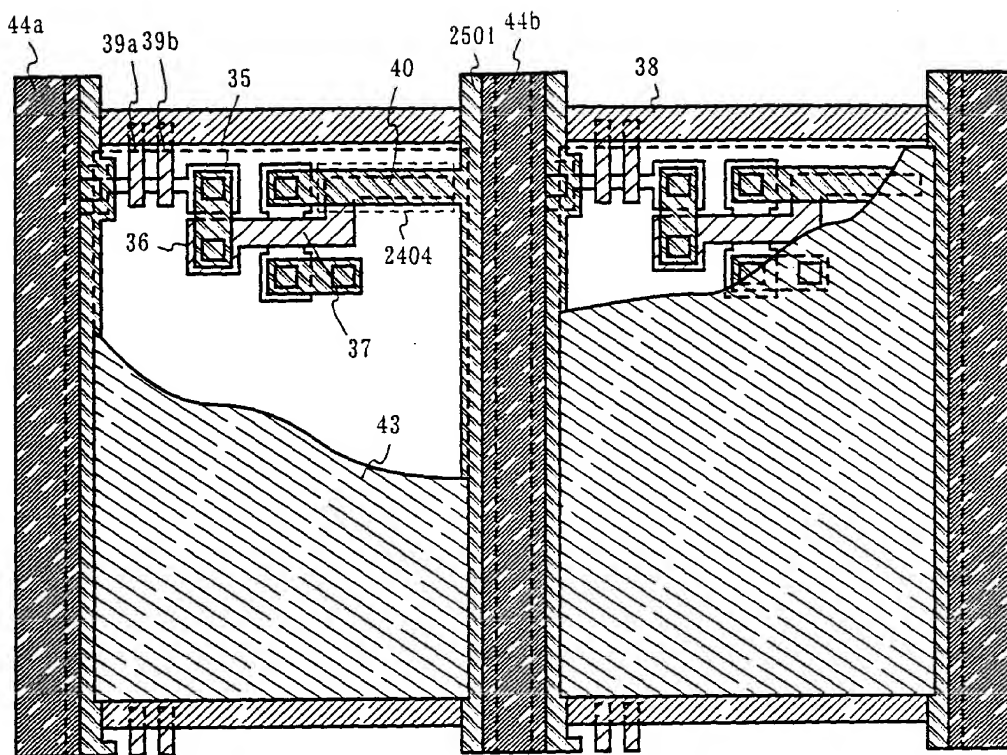


Fig. 20B



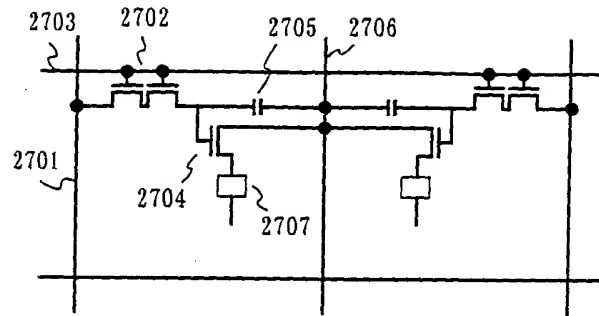


Fig. 22A

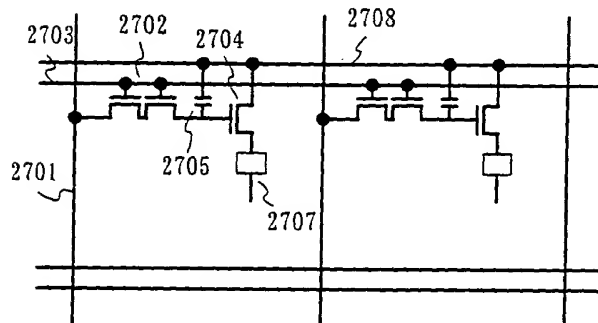


Fig. 22B

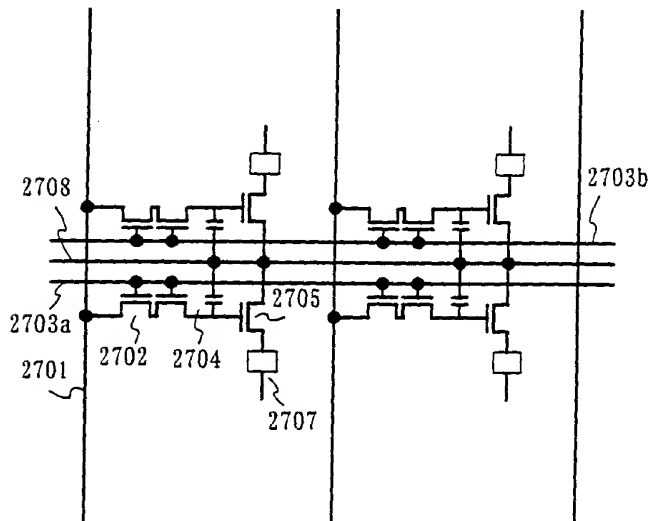
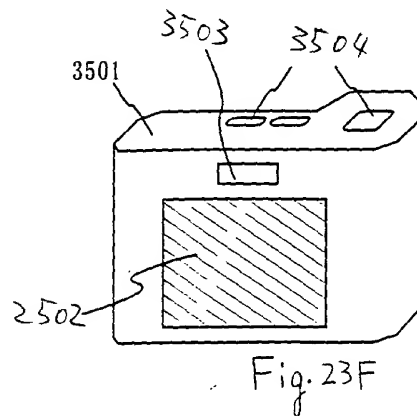
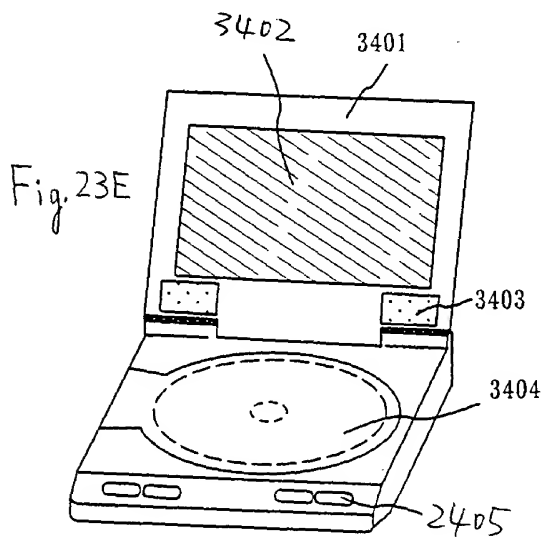
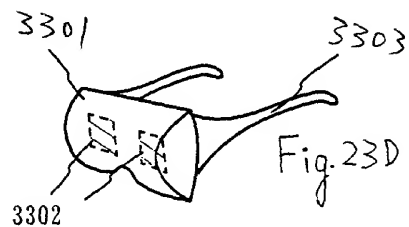
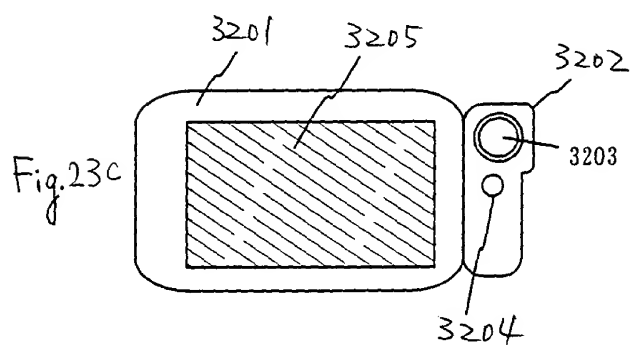
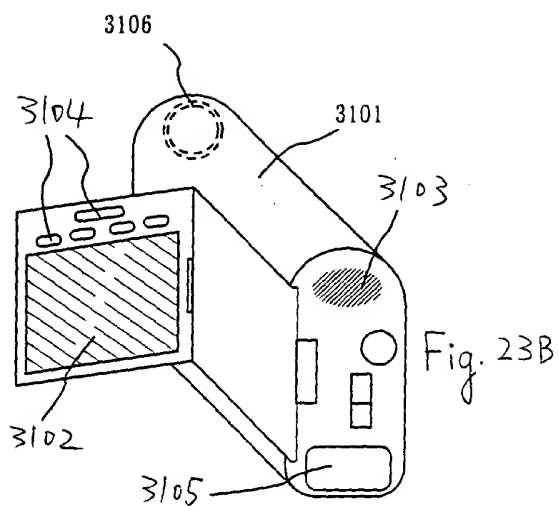
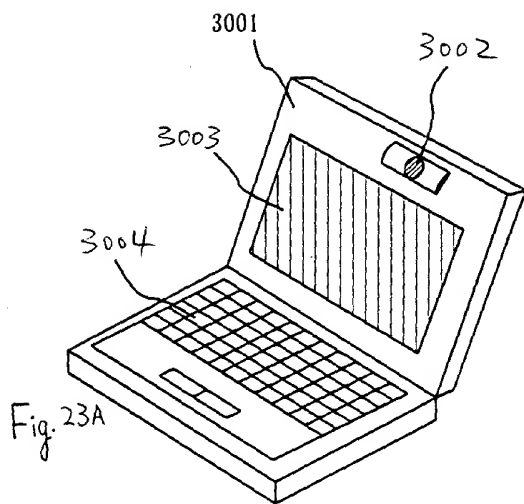


Fig. 22C



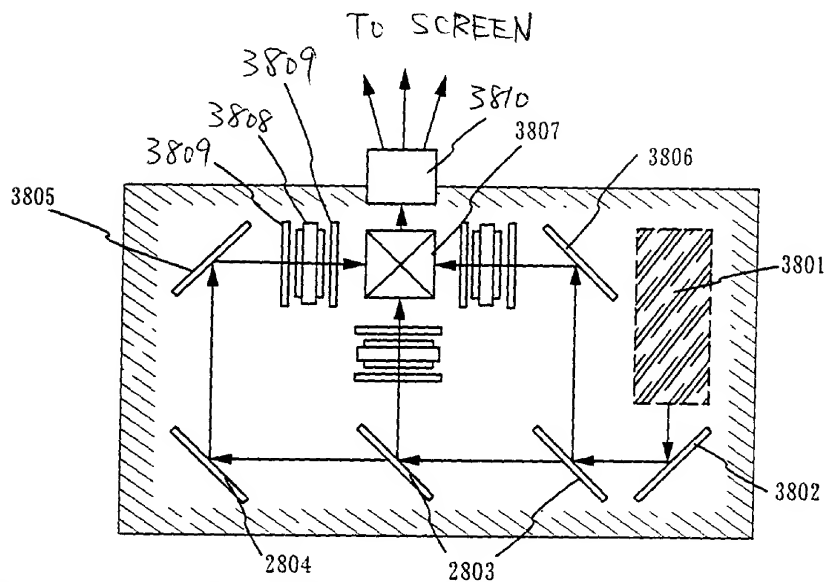
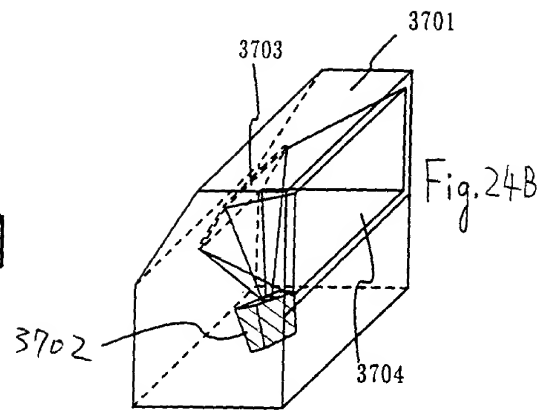
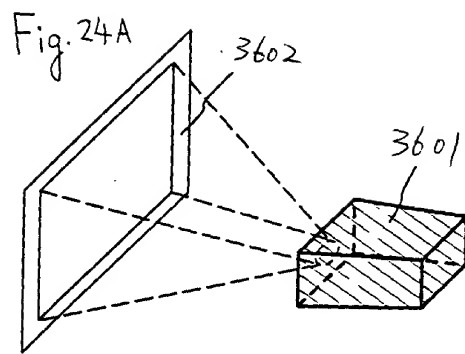


Fig. 24C PROJECTION DEVICE (THREE PLATE TYPE)

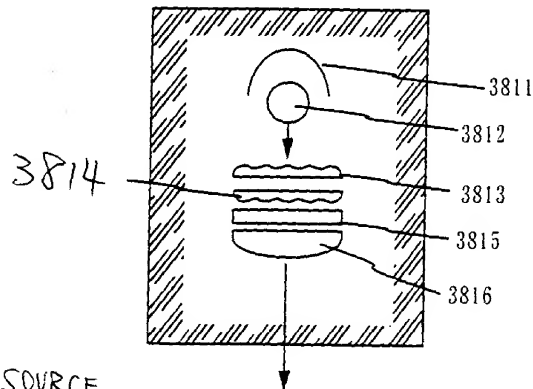


Fig. 24D LIGHT SOURCE OPTICAL SYSTEM

